



**In re Application of:**

Chen, et al.

**Serial No.: 10/611,589**

Confirmation No.: 5241

Filed: June 30, 2003

**For: Method and Apparatus for  
Annealing Copper Films**

[illegible]

**Group Art Unit: 1742**

Examiner: Unknown

**MAIL STOP PGPUB DRAWINGS**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Dear Sir:

**CERTIFICATE OF MAILING**  
**37 CFR 1.8**

I hereby certify that this correspondence is being deposited on 12/5, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop PGPUB Drawings, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.


12/5/03 Keith A. Zuck  
Date Signature

## SUBMISSION OF FORMAL DRAWINGS

Attached please find (8) sheets of formal drawings, with gummed labels identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

Any comparison fee should be charged to Deposit Account No. 20-0782/AMAT/1717.D2/KMT. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at (713) 623-4844.

Respectfully submitted,

  
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